

IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

#22
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Applicant(s): **Chin, et al.**

Case: **5017/ISM/CORE MCVD/SB**

Serial No.: **Not yet assigned**

Filed: **Herewith**

Group Art Unit: **Not yet assigned**

Title: **ATOMIC LAYER DEPOSITION APPARATUS**

THE COMMISSIONER OF PATENTS AND TRADEMARKS
Washington, DC 20231

S I R:

Disclosure Statement Under 37 C.F.R. 1.56 and 1.98

Pursuant to 37 C.F.R. 1.56, the documents (copies enclosed) listed on form PTO-1449, submitted herewith, are disclosed. Under Rule 37 C.F.R. 1.98(a), the Applicants submit that no specific comments are necessary for any of the cited English language publications having an enclosed English language translation or abstract.

Respectfully submitted,

July 5, 2001
Date

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